

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Michael W. Price, et al

Serial No:

10/629,397

Examiner:

Filed:

7/29/2003

Group Art Unit: 1765

For:

SCATTER FREE UV OPTICAL

FLUORIDE CRYSTAL ELEMENTS FOR

LESS THAN 200NM LASER LITHOGRAPHY AND METHODS

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §§ 1.56, 1.97 – 1.98

Commissioner of Patents Alexandria, VA 22313-1450

Dear Sir:

The Examiner's attention is hereby directed to the following reference(s) listed on the attached Form PTO-1449 for consideration in connection with the examination of the above-identified patent application. One copy of the reference(s) is enclosed.

Each of the enclosed reference(s) was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the enclosed documents constitute "prior art." If it should be determined that any of the submitted documents do not constitute "prior art" under United States law, applicant(s) reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents.

Applicant(s) further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the enclosed references, should one or more of the references be applied against the claims of the present application.

Respectfully submitted,

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Date: 15 January 2004

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner of Patents, Alexandria, VA 22313-1450 on

Date of Deposit

Walter M. Douglas

Name of applicant, assignee, or Registered Representative

Signature

Date of Signature

Revision: September 1, 2002 F:\MDC Forms\IDSCover D 5-1-03.dot RM PTO-1449 (MODIFIED)

LIST OF PATENTS AND
PUBLICATIONS

PAGE OR APPLICANTS INFORMATION

SERIAL NO.

SP02-174

10/629397

FILING DATE 7/29/2003

GROUP: 1765

REFERENCE DESIGNATION

DISCLOSURE STATEMENT

U.S. PATENT DOCUMENTS

TOT ENERGE DESIGNATION		C.B. TATELLI DOCUMENTS			T	,	
Examiner Initial		Document Number	Date	Name	Class	Sub- Class	Filing Date if Approp.
	AA	6,093,245	7/25/00	Hammond, et al	117	200	
	AB	2001/0008540	7/19/01	Oba, et al	372	1041	
	AC						
	AD						
	ΑE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						<u> </u>

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Sub- Class	Trans Yes	lation No
AL	EP1026548A2	9/8/00	Europe				
AM	WO 01/00907A1	1/4/01	PCT				
AN							
 AO	·						
 AP							
AQ							

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

AR	"Behaviors of trace amounts of metal-fluoride impurities in CaF ₂ single-crystal grown by Stockbarger's method", Yonezawa, et al Journal of Crystal Growth 236 (2002) 281-289
AS	
AT	
AU	
AV	
AW	

EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement-PTO-1449 (Modified)